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TO: U.S. Patent & Trademark Office DATE: February 3, 2004  
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FROM: Eugene J. Bernard, Esq. TIME: \_\_\_\_\_  
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**MESSAGE:****FOR INTERNAL PURPOSES ONLY**TELECOPY/FAX NUMBER: 703.872.9306CLIENT NUMBER: 81848.0016.001ATTORNEY BILLING NUMBER: 73049

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Serial No. 09/546,174

Application of: Chih-Chien LIU, et al.

Filed: April 11, 2000

Art Unit: 1711

Examiner: R.A. SERGENT

Attorney Docket No. UMC-96-279 CON

For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS

Confirmation No.: 4793

Customer No.: 25235

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office

1. Amendment and Response to the Office Action Mailed December 23, 2003; and
2. Amendment Fee Transmittal Form (2 copies)

On February 3, 2004

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Daniel J. Stephenson

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**OFFICIAL**Attorney Docket No. UMC-96-279 CON  
Client Matter No. 81848.0016.001

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No. 09/546,174	Confirmation No.: 4793
Application of: LIU, Chih-Chien et al	Customer No.: <b>25235</b>
Filed: April 11, 2000	
Art Unit: 1711	
Examiner: SERGENT, R.A.	
Attorney Docket No. UMC-96-279 CON	
For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS	

AMENDMENT AND RESPONSE TO THE OFFICE ACTION  
MAILED DECEMBER 23, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

An Office Action was mailed in the above case December 23, 2003.  
Please reconsider the case in light of the amendment and remarks that follow.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.